

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned
Examiner: To Be Assigned

In re PATENT APPLICATION of

Applicant(s) : Osamu KATO

Appln. No. : To Be Assigned

Filed : October 21, 2003

For : A METHOD FOR FABRICATING A GATE)
MASK OF A SEMICONDUCTOR DEVICE)

Atty. Dkt. : FUJI 138

**INFORMATION
DISCLOSURE
STATEMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are English-language Abstracts of two Japanese patent publications. Any further relevance of the publications can be gleaned from their description on pages 3-5 of the specification. The publications are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)
RABIN & BERDO, P.C.
CUSTOMER NO. 23995
(202) 371-8976
(202) 408-0924 fax

October 21, 2003
Date

RHB:tl

FEE ENCLOSED: \$
Please charge any further
fe to our Deposit Acc unit
No. 18-0002

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT			Atty Docket		Application No.		
			FUJI 138		To Be Assigned		
			Applicant				
			Osamu KATO				
			Filing Date		Group Unit		
			October 21, 2003		To Be Assigned		
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AΘ						
	AC						
	AD						
	AE						
	AF						
	AC						
	AH						
	AI						
	AJ						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AK	JP 5029301	02/05/93	Japan			Abstract
	AL	JP 5171443	07/09/93	Japan			Abstract
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
	AP						
	AQ						
	AR						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							